

Table of Contents

Preface

Femtosecond Time-Resolved Microscopy of Laser-Induced Morphology Changes D. von der Linde	1
Low Temperature Deposition and Crystallization of Silicon by Means of Laser Techniques M. Hirose	7
Femtosecond-Pulse Laser Microstructuring of Semiconducting Materials W. Kautek and J. Krüger	17
Modification of Foreign Atom Concentrations and Profiles in Silicon and $\text{Si}_{1-x-y}\text{Ge}_x\text{C}_y$ Alloys by Laser Chemical Etching J. Boulmer, A. Desmur, B. Bourguignon, J.-. Ozenne, R. Laval, A. Aliouchouche, D. Débarre and J.-. Budin	23
Properties of Recrystallized Amorphous Silicon Prepared by XeCl Excimer Laser Irradiation I. Ulrych, K.M.A. El-Kader, V. Cháb, J. Kocka, P. Prikryl, V. Vydra and R. Cerný	29
Kinetics of Laser-Induced Synthesis and Crystallization of Thin Semiconductors Films K. Kolev and L.D. Laude	35
Surface Patterning and Thin-Film Formation by Pulsed-Laser Ablation D. Bäuerle, E. Arenholz, J. Heitz, S. Proyer, E. Stangl and B. Luk'yanchuk	41
Laser Patterning of $\text{CuInSe}_2/\text{Mo}/\text{SLS}$ Structures for the Fabrication of CuInSe_2 Sub Modules L. Quercia, S. Avagliano, A. Parreta, E. Salza and P. Menna	53
UV-Excimer Laser Ablation Patterning of II-VI Compound Semiconductors P.H. Key, D. Sands and F.X. Wagner	59
Fabrication and Characterisation of N^+ Doped Laser Crystallised Polysilicon E. Al-Nuaimy, J.M. Marshall, T.E. Dyer, A.R. Hepburn and J.F. Davies	67
Pulsed Laser Ablation: A Method for Deposition and Processing of Semiconductors at an Atomic Level J.J. Dubowski	73
Vacuum Ultraviolet Deposition of Silicon Dielectrics I.W. Boyd	81
Conditions for Heterophase Junction Formation in Laser Deposited PbTe Films V. Gaydarova	93
High-Quality Narrow-Gap Thin Films Produced by Quasi-Continuous-Wave IR-Laser-Assisted Evaporation S.V. Plyatsko and Y.S. Gromovoj	99
Laser-Induced Etching of Si Surfaces; the Effect of Weak Background Light H. Grebel and T. Gayen	105
Gas-Dynamic Effects in Laser Pulse Sputtering of Aluminium A. Peterlongo, A. Miotello and R. Kelly	109
Laser Deposited Phthalocyanine- and Fullerene-Based Photovoltaic Cells A.I. Shevalevskii, V.P. Poponin and L.L. Larina	117
Synthesis of $\beta\text{-FeSi}_2$-Films by Pulsed Laser Deposition M. Panzner, H. Mai, B. Schöneich, B. Selle, H. Lange, W. Henrion, T. Wittke, A. Lenk, A. Teresiak and R. Grötzschel	123
Complex Semiconductor Compound Targets for Pulsed Laser Deposition H. Dittrich, M. Klose, M. Brieger, R. Schäffler and H.W. Schock	129
Pulsed Laser Deposition and Characterization of CuInSe_2 Thin Films for Solar Cell Applications R. Schäffler, M. Klose, M. Brieger, H. Dittrich and H.W. Schock	135
Laser Characterization of Semiconductors M. Stutzmann	141
Silicon Surface Nonlinear Optics C. Jordan, G. Marowsky, R. Buhleier, G. Lüpke, E.J. Canto-Said, Z. Gogolak and J. Kuhl	153

Mapping of Defect-Related Silicon Properties with the ELYMAT Technique in Three Dimensions	
J. Carstensen, W. Lippik and H. Föll	159
Laser Examined AlGaAs-Solar Cells with Wide-Gap Tunneling-Thin Cap Layers	
V.M. Andreev, V.P. Kvestikov, V.R. Larionov and V. Rummyantsev	165
Use of Photoinduced Microwave Reflection for the Non-Destructive Characterization of Solar Cell Materials and Device Structures	
J.M. Borrego	171
Photothermal Deflection Spectroscopy on Amorphous Semiconductor Heterojunctions and Determination of the Interface Defect Densities	
F. Becker, R. Carius, J.-. Zettler, J. Klomfass, C. Walker and H. Wagner	177
Summary Abstract: Laser Surface Photovoltage Spectroscopy - A New Tool for Determination of Surface State Distributions and Properties	
L. Kronik, L. Burstein, E. Fefer, M. Leibovitch and Y. Shapira	183
Photorefractive Two Wave Mixing and Steady State Photocurrent Gratings for Semiconductor Characterization	
B. Smandek, Y. Ding, V. Hagemann, S. Gohlke, A. Wappelt and R. Wendt	185
A Novel Contactless Approach for Accurate Measurements of Electron-Hole Recombination Lifetime	
G. Breglio, A. Cutolo, P. Spirito and L. Zeni	191
Raman Studies of Doped Poly-Si Thin Films Prepared by Pulsed Excimer Laser Annealing	
A. Compaan, M.E. Savage, U. Jayamaha, T. Azfar and A. Aydinli	197
Near Infrared Quasi-Elastic Light Scattering Spectroscopy of Electronic Excitations in III-V Semiconductors	
B.H. Bairamov, I.P. Ipatova, G. Irmer, J. Monecke, V.K. Negoduyko, V.A. Voitenko and V.V. Toporov	203
Laser Pulsed Induced Microwave Conductivity and Spectroscopic Ellipsometry Characterization of Helium and Hydrogen Plasma Damage of the Crystalline Silicon Surface	
H.C. Neitzert, N. Layadi, P. Roca i Cabarrocas, R. Vanderhaghen and M. Kunst	209
Laser Diagnostics of InSb Surface	
G.V. Beketov and A.I. Liptuga	215
Contactless Characterization of Semiconductors Using Laser-Induced Surface Photo-Charge Voltage Measurements	
A. Abbate, P. Rencibia, O. Ivanov, G. Masini, F. Palma and P. Das	221
Narrowing of Photoluminescence Line from Single Quantum Well under High Excitation Levels	
D.G. Revin and V.Y. Aleshkin	227
Resonance Raman Spectroscopy of Langmuir-Blodgett Films from Metallo-Phthalocyanines	
L.L. Larina, N.N. Melnik, V.P. Poponin, O.I. Shevaleevskii and A.A. Kalachev	231
Raman and Nonlinear Light Scattering from Undersurface Layers of Ion Implanted Silicon Crystals	
V. Gorelik	237
Raman Study of "Boson Peak" in Amorphous Silicon: Dependence on Hydrogen and Carbon Content	
M. Ivanda, I. Hartmann, F. Duschek and W. Kiefer	243
Structural Investigation of Microcrystalline Silicon	
P. Hapke, M. Luysberg, R. Carius, F. Finger and H. Wagner	249
Recombination Lifetime in Silicon from Laser Microwave Photoconductance Decay Measurement	
C.H. Ling, H.K. Teoh, W.K. Choi, T.Q. Zhou and L.K. Ah	255
Investigation of Electronic Transport in Semiconductor Junctions by Photoinduced Laser Beam Deflection	
P. Grunow, R. Schieck and M. Kunst	259
Nondestructive and Contactless Evaluation of Electrical and Thermal Properties of Thin Semiconducting Layers	
H.D. Geiler	265
Diagnostics of Semiconductor Surface by Laser-Induced Photovoltage	
B. Pohoryles and A. Morawski	273

Characterization of the M. O. S. Structure by the Surface Photoelectrical Voltage Method B. Akkal, Z. Benamara, M. Chellali, H. Sehil and B. Gruzza	279
Optical Second-Harmonic Generation (SHG) on Semiconductor Electrodes by Means of Femtosecond and Nanosecond-Pulse Lasers W. Kautek, N. Sorg and J. Krüger	285
Optical and Electrical Properties of Semiconducting Thin Films Near the Deposition Substrate J. Ebothe	291
Crystalline Silicon Materials and Solar Cells J. Knobloch and A. Eyer	297
The Use of Lasers in the Fabrication of High-Efficiency Silicon Solar Cells C.B. Honsberg and M.A. Green	311
A Laser System for Silicon Solar Cell Processing: Design, Setup and Operation L. Pirozzi, U.B. Vetrella, M. Falconieri and E. Salza	319
Light and Electron Beams Scanning of Solar Cells S. Mil'shtein, B. Bakker, S. Iatrou, D. Kharas and R.O. Bell	325
Characterization of Textured Transparent Conductive Oxides for Thin Film Solar Cell Applications J. Wallinga, J. Daey Ouwens, R.E.I. Schropp and W.F. van der Weg	331
Application of Steady-State Photocarrier Grating Technique for Determination of Ambipolar Diffusion Lengths in Cu (In, Ga) (S, Se)₂ - Thin Films for Solar Cells S. Zweigart, R. Menner, R. Klenk and H.W. Schock	337
Laser Raman Scattering Characterization of A³B⁵ Compounds and Photovoltaic Structures V.M. Andreev, M.V. Cherotchenko, L.B. Karlina, A.M. Mintairov, V.P. Khvostikov and S.V. Sorokina	343
Resonant Raman and Photoluminescence of CdTe Films for PV Using Diode Lasers A. Fischer, A. Compaan, A. Dane and A. Aydinli	349
Laser-Aided Measurements of Electric Fields on III-V Semiconductor Structures Using Modulation Spectroscopy: Solar Cell P-N Junctions and [111] Strained Layer Superlattices R.G. Rodrigues, K. Yang, L.J. Schowalter and J.M. Borrego	355